



## AN 358 Improved Detection Limits in SIMS Measurements of SiC

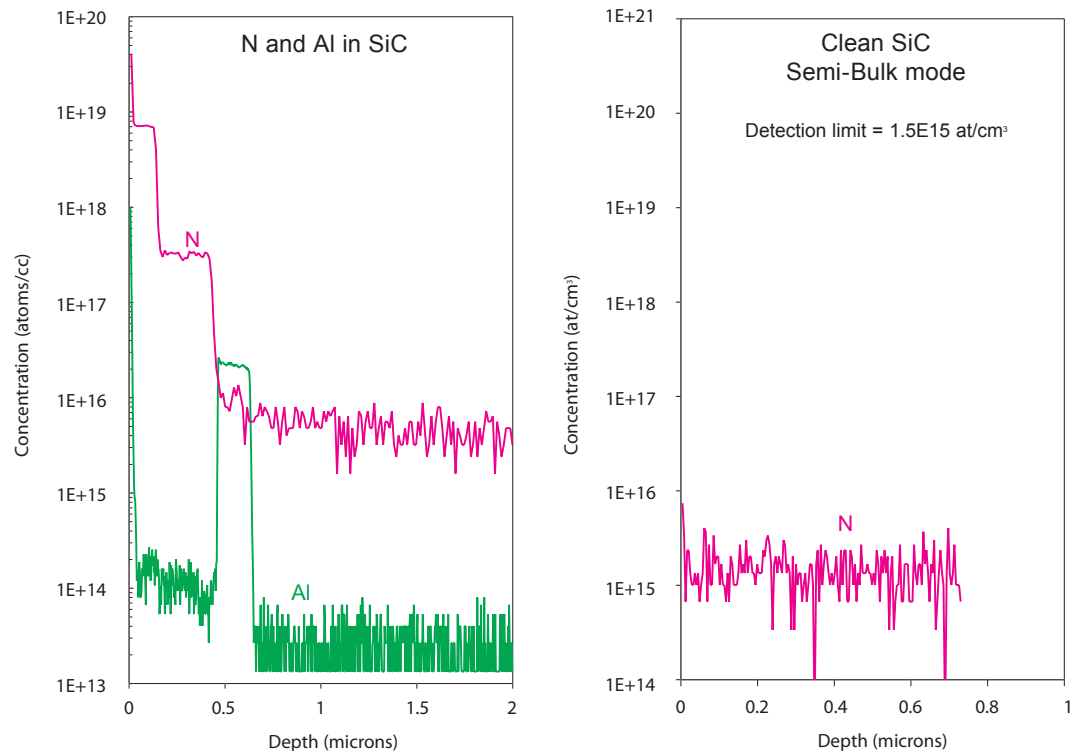
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### Discussion

SiC is a very important material for high-power, high-temperature, and high-radiation devices. The requirements for improving yields demand lower levels of impurities. In terms of SIMS this means the ability to measure very low doping or contamination levels in SiC. SiC material vendors and device manufacturers would benefit from the solution to this problem.

Doping levels in SiC are becoming very low. This requires lower allowable impurity concentrations. The analytical need is to provide accurate measurements to be able to distinguish differences in doping levels and presence or absence of impurities or unintentional dopants. Due to its unique capabilities of high detection sensitivity for a variety of elements, Secondary Ion Mass Spectrometry (SIMS) is an essential tool for characterization of dopants and impurities in SiC material.

We have adapted two SIMS tools for specialized analysis of three major dopant species in SiC: B, Al, and N. These two tools are also dedicated to these measurements. This provides us the capability to measure dopant or contamination levels 5-20 times lower than before. The depth profile (Figure 1) shows Al contamination in N doped layers; N contamination in the Al doped epi-layer; and detection levels of  $2 \times 10^{13}$  at/cm<sup>3</sup> for Al and  $5 \times 10^{15}$  at/cm<sup>3</sup> for N. B detection levels are about  $1 \times 10^{13}$  at/cm<sup>3</sup>. Figure 2 illustrates a semi-bulk mode analysis with a N detection level of  $\leq 2 \times 10^{15}$  at/cm<sup>3</sup>. SIMS is thus a vital tool for determining the doping concentration and resolving whether impurities are present.



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**United States Locations**

Tempe, Arizona  
+1 480 239 0602 info.az@eaglabs.com  
+1 602 470 2655 fax

Sunnyvale, California  
810 Kifer Road  
+1 408 530 3500 info.ca@eaglabs.com  
+1 408 530 3501 fax

1135 E Arques Avenue  
+1 408 738 3033  
+1 408 738 3035 fax

785 Lucerne Drive  
+1 408 737 3892  
+1 408 737 3916 fax

Peabody, Massachusetts  
+1 978 278 9500 info.ma@eaglabs.com  
+1 978 278 9501 fax

Chanhassen, Minnesota  
+1 952 828 6411 info.mn@eaglabs.com  
+1 952 828 6449 fax

East Windsor, New Jersey  
+1 609 371 4800 info.nj@eaglabs.com  
+1 609 371 5666 fax

Syracuse, New York  
+1 315 431 9900 info.ny@eaglabs.com  
+1 315 431 9800 fax

Raleigh, North Carolina  
+1 919 829 7041 info.nc@eaglabs.com  
+1 919 829 5518 fax

Round Rock, Texas  
+1 512 671 9500 info.tx@eaglabs.com  
+1 512 671 9501 fax

**International Locations**

Shanghai, China  
+ 86 21 6879 6088 info.cn@eaglabs.com  
+ 86 21 6879 9086 fax

Tournefeuille, France  
+ 33 5 61 73 15 29 info.fr@eaglabs.com  
+ 33 5 61 73 15 67 fax

Frankfurt, Germany  
+ 49 (0) 693053213 info.de@eaglabs.com  
+ 49 (0) 69307941 fax

Tokyo, Japan  
+ 81 3 5396 0531 info.jp@eaglabs.com  
+ 81 3 5396 1930 fax

HsinChu, Taiwan  
+ 886 3 5632303 info.tw@eaglabs.com  
+ 886 3 5632306 fax

Uxbridge, United Kingdom  
+ 44 (0) 1895 811194 info.uk@eaglabs.com  
+ 44 (0) 1895 810350 fax